

FORM PTO-1449 U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		ATTY. DOCKET NO.		SERIAL NO.	
		U 01585		10/542,123	
		APPLICANT			
		Vladimir Pavlovich POPOV et al.			
		FILING DATE		GROUP	
		12/9/05		2823	

U.S. PATENT DOCUMENTS					
EXAMINER INITIALS	REFERENCE DESIGNATION	DOCUMENT NUMBER	DATE	NAME	FILING DATE IF APPROPRIATE
QVJ	AA	6,323,109	11/2001	Okonogi	
QVJ	AB	6,306,730	10/2001	Mitani et al.	
QVJ	AC	5,374,564	12/1994	Bruel	
	AD				
	AE				
	AF				
	AG				
	AH				
	AI				
	AJ				
	AK				

FOREIGN PATENT DOCUMENTS						
EXAMINER INITIALS	REFERENCE DESIGNATION	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
QVJ	AL	2 164 719	03/2001	RU	X	
QVJ	AM	197 53 494	10/1998	DE		X
	AN					
	AO					
	AP					

OTHER ART (Including Author, Title, Date, Pertinent Dates, Etc.)		
QVJ	AQ	Partial English Translation of RU 2 164 719 dated March 27, 2001
QVJ	AR	Tong, Q.-Y., et al. "Semiconductor Wafer Bonding: Science and Technology" A Wiley-Interscience Publication, pp 52 and 62
	AS	

EXAMINER Quovaunda Jefferson	DATE CONSIDERED 06/05/2006
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EXAMINER:	Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
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